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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shunpei Yamazaki et al. Art Unit : 2823
Serial No. : 10/024,850 Examiner : William D Coleman
Filed : December 18, 2001 Confirmation No.: 8129
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE
SAME

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Copies of the references listed on the attached form PTO-1449 are enclosed.

Submitted herewith is an English translation of the following foreign language
references, or portions thereof:


Desig. ID	Source
AM	JAPAN 07-066425 - English Abstract: DIALOG(R) File 345: Inpadoc/Fam. & Legal Stat (2004); Accession No. 12294215 and family to U.S. Patent Application Publication No. 2003/0054595 (Desig. ID "AA"), U.S. Patent No. 5,534,716 (Desig. ID "AC"), U.S. Patent No. 5,616,506 (Desig. ID "AD"), U.S. Patent No. 6,194,254 (Desig. ID "AG") and U.S. Patent No. 6,482,686 (Desig. ID "AI")
AN	JAPAN 07-094757 - English Abstract: DIALOG(R) File 345: Inpadoc/Fam. & Legal Stat (2004); Accession No. 12315216 and family to U.S. Patent Application Publication No. 2003/0022467 (Desig. ID "AB"), U.S. Patent No. 6,071,764 (Desig. ID "AE"), U.S. Patent No. 6,077,758 (Desig. ID "AF") and U.S. Patent No. 6,455,401 (Desig. ID "AH").

This statement is being filed after a first Office action on the merits, but before receipt of a final Office action or a Notice of Allowance. A check for \$180 in payment of the late submission fee of §1.17(p) is enclosed. Please apply any other charges or credits to Deposit Account No. 06-1050.

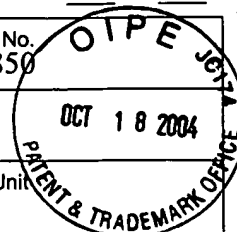
Respectfully submitted,

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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-188002	Application No. 10/024,850
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Shunpei Yamazaki et al.	
		Filing Date December 18, 2001	Group Art Unit 2823



U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	2003/0054595 A1	03/20/2003	Takemura			10/21/2002
	AB	2003/0022467 A1	01/30/2003	Zang et al.			09/24/2002
	AC	5,534,716	07/09/1996	Takemura			08/23/1994
	AD	5,616,506	04/01/1997	Takemura			12/21/1994
	AE	6,071,764	06/06/2000	Zhang et al.			06/28/1995
	AF	6,077,758	06/20/2000	Zhang et al.			12/18/1996
	AG	6,194,254 B1	02/27/2001	Takemura			03/28/1997
	AH	6,455,401 B1	09/24/2002	Zhang et al.			05/23/2000
	AI	6,482,686 B1	11/19/2002	Takemura			07/12/2000
	AJ						
	AK						
	AL						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AM	07-066425	03/10/1995	JAPAN			Abstract	
	AN	07-094757	04/07/1995	JAPAN			Abstract	
	AO							
	AP							
	AQ							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AR	
	AS	
	AT	
	AU	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	